Modulated Photoconductivity in YB₆₆

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The modulated photoconductivity was measured in single crystal YB_{66} , essentially consisting of B_{12} icosahedral clusters like many other boron-rich borides. A model, in which localized states participate both in photocarrier generation and trapping well explains the phase shift between excitation and photocurrent. For the localized states involved, an ionization energy of 0.19 eV is estimated. \bigcirc 1997 Academic Press

INTRODUCTION

The physical properties and the electronic structures of boron and boron-rich borides have characteristics reminding of disordered solids, which characteristics are assigned to B_{12} clusters constructing their structures (1). Among these materials YB_{66} has the largest unit cell with more than 1600 atoms (2), suggesting a higher disorder of B_{12} clusters than in simpler boron and boride structures. Up to now, only few physical properties of single crystal YB_{66} have been reported (3, 4), e.g., the electrical conductivity describable by Mott's law of variable-range hopping and the edge absorption reminding of the Urbach tail of amorphous semiconductors. The electronic structure has remained unsolved.

In the present study, localized states and carrier generation in YB_{66} were analyzed by modulated photocurrent (MPC) measurements determined by carrier generation, trapping in localized states, reexcitation, and recombination (5,6).

EXPERIMENT

A high-quality single crystal was prepared by an indirect heating floating zone method; the chemical composition of the feed rod was $\lceil B \rceil / \lceil Y \rceil = 56$. For sample preparation,

see Ref. (7). The ingot was sliced and the surfaces were high grade polished (about 1 cm in diameter and 1 mm in thickness).

For excitation the chopped light of an Ar-ion laser (488.8 nm, 2.54 eV) illuminated the surface area between two evaporated aluminum electrodes. By lock-in technique amplitude and phase of the modulated photocurrent were simultaneously measured. The frequency dependence of the amplitude and the phase induced by the apparatus were corrected according to reference measurements with a fast Si-photodiode (see Fig. 1). The modulation frequency was varied from 5 to 3500 Hz.

RESULTS AND DISCUSSION

Frequency dependence of amplitude and phase shift of the photocurrent at several temperatures are shown in Figs. 2a and 2b. A first attempt to describe the results by a simple model (5), taking interband excitation, trapping in localized states, reexcitation, and recombination via recombination states into account, was not successful. Therefore the results were analyzed with a model (6) considering two kinds of carrier generation: (i) photoexcitation directly into the conduction band and (ii) photoexcitation to localized states near the conduction band and subsequent thermal excitation into the conduction band (see Fig. 3). Although it is assumed in Fig. 3 that photocarriers are electrons in the conduction band, the model also holds if the photocarriers are holes in the valence band. Then the phase shift consists of two parts,

$$\phi_1 = \tan^{-1} \varpi \tau z, \qquad [1]$$

$$\phi_2 = \tan^{-1} \frac{(K_2/K_1)(\omega/P_s)}{1 + (K_2/K_1) + (\omega/P_s)^2},$$
 [2]

196 SAKAIRI ET AL.

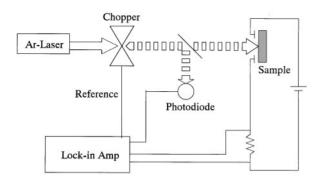
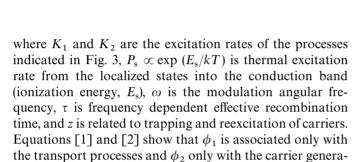


FIG.1. Block diagram of the setup for measuring the modulated photoconductivity.



The frequency dependence of ϕ_2 exhibits a maximum moving toward lower frequencies, when the temperature decreases because $P_{\rm s}$ is proportional to $\exp(E_{\rm s}/kT)$. A plot of ϕ_2 as a function of $\omega/P_{\rm s}$ yields the temperature independence of ϕ_2 . Then the results in Fig. 2b can be normalized as shown in Fig. 4 by moving the phase shift curves along the

tion processes.

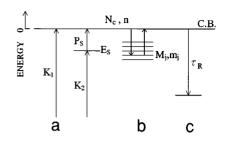
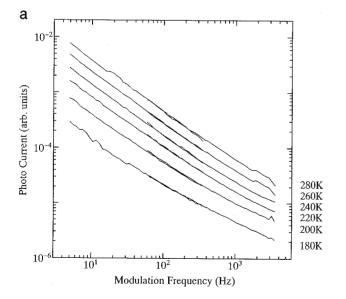


FIG. 3. Energy level scheme for the model of the modulated photoconductivity, showing the energy level locations and the process taken into account.

horizontal axis using a temperature-dependent normalizing factor, $1/P_s$. Temperature dependence of this factor assigned an activation energy of 0.19 eV (Fig. 5). This is the ionization energy of the localized state.

According to these results two energy band schemes for YB_{66} seem possible:

- (i) a mobility gap of 2.73 eV equal to the sum of the optical excitation energy (2.54 eV) and the thermal activation energy (0.19 eV) that is very large when compared with the absorption spectrum exhibiting at 0.7 eV an absorption coefficient of 10^3 cm^{-1} (3);
- (ii) a large density of localized states in a distance of 0.19 eV from the mobility edge, so that the carrier excitation into these localized states makes a large contribution toward the photoconduction process even if the photon energy is larger than the mobility gap.



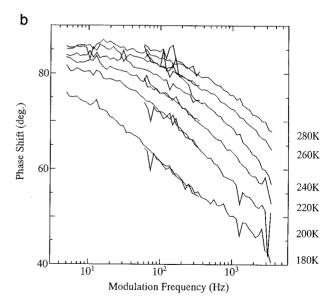


FIG. 2. Modulation frequency dependence of photocurrent (a) and phase shift (b) of single crystal YB₆₆ measured at several temperatures.

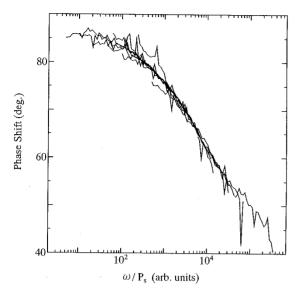
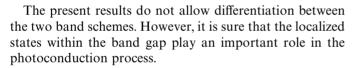


FIG. 4. The particular curve of the phase shift, appearing when the results of the modulation frequency dependence at respective temperatures are moved along the horizontal axis to coincide with the result at 280 K. This procedure corresponds to the conversion of horizontal axis from ω into ω/P_s .



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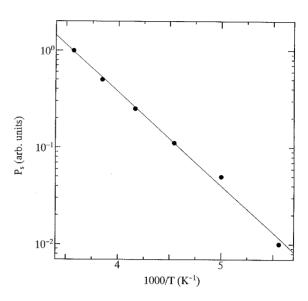


FIG. 5. Temperature dependence of the factor corresponding to the thermal release rate P_s (see text).

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